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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/597,903	08/11/2006	Thomas William Beck	2004P87074WOUS	7739	
28524 SIEMENS CO	7590 01/09/200	8	EXAMINER		
INTELLECTU	AL PROPERTY DEPA	ARTMENT	SHABMAN, MARK A		
170 WOOD A' ISELIN, NJ 08	VENUE SOUTH		ART UNIT	PAPER NUMBER	
ISEEIN, NO OO	030	·	2856		
			· MAIL DATE	DELIVERY MODE	
			01/09/2008	PAPER	

Please find below and/or attached an Office communication concerning this application or proceeding.

The time period for reply, if any, is set in the attached communication.

	Application No.	Applicant(s)	
	10/597,903	BECK ET AL.	
Office Action Summary	Examiner	Art Unit	
	Mark Shabman	2856	
The MAILING DATE of this communication a	ppears on the cover sheet w	ith the correspondence address	
Period for Reply		IONELIAN OR THEFT	\ <u>'</u> 0
A SHORTENED STATUTORY PERIOD FOR REP WHICHEVER IS LONGER, FROM THE MAILING - Extensions of time may be available under the provisions of 37 CFR after SIX (6) MONTHS from the mailing date of this communication. - If NO period for reply is specified above, the maximum statutory perior - Failure to reply within the set or extended period for reply will, by state Any reply received by the Office later than three months after the mail earned patent term adjustment. See 37 CFR 1.704(b).	DATE OF THIS COMMUNI 1.136(a). In no event, however, may a rd will apply and will expire SIX (6) MOI ute, cause the application to become A	CATION. reply be timely filed ITHS from the mailing date of this communic BANDONED (35 U.S.C. § 133).	
Status			
1) Responsive to communication(s) filed on 16	November 2007.		
	nis action is non-final.		
3) Since this application is in condition for allow	ance except for formal mat	ters, prosecution as to the merit	ts is
closed in accordance with the practice under	Ex parte Quayle, 1935 C.E). 11, 453 O.G. 213.	
Disposition of Claims			
4)⊠ Claim(s) <u>2-12</u> is/are pending in the application	on.	,	
4a) Of the above claim(s) is/are withdr	awn from consideration.		
5) Claim(s) is/are allowed.			
6)⊠ Claim(s) <u>2-12</u> is/are rejected.			
7) Claim(s) is/are objected to.			
8) Claim(s) are subject to restriction and	or election requirement.		
Application Papers			
9) The specification is objected to by the Examin	ner.		
10) The drawing(s) filed on is/are: a) □ ac	• •	•	
Applicant may not request that any objection to the			
Replacement drawing sheet(s) including the corre	_		
11) The oath or declaration is objected to by the l	Examiner. Note the attacher	Office Action of John PTO-152	2. .
Priority under 35 U.S.C. § 119			
12)⊠ Acknowledgment is made of a claim for foreig	gn priority under 35 U.S.C. {	§ 119(a)-(d) or (f).	
a)⊠ All b)□ Some * c)□ None of:	aka bawa bawa asasiwa d		
1. Certified copies of the priority docume		polication No.	
2. Certified copies of the priority docume3. Copies of the certified copies of the pr			.
application from the International Bure	•	received in this Hadional Otage	,
* See the attached detailed Office action for a li		received.	
	·		
Attachment(s) 1) Notice of References Cited (PTO-892)	A)	Summary (PTO-413)	
2) Notice of Draftsperson's Patent Drawing Review (PTO-948)	Paper No(s)/Mail Date	
3) Information Disclosure Statement(s) (PTO/SB/08) Paper No(s)/Mail Date Modern	5) Notice of I 6) Other:	nformal Patent Application	•
i apel No(S)/Ivian Date III/UT	0) 🗀 Other	 ·	•

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DETAILED ACTION

Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(e) the invention was described in (1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent or (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effects for purposes of this subsection of an application filed in the United States only if the international application designated the United States and was published under Article 21(2) of such treaty in the English language.

Claim 12 is rejected under 35 U.S.C. 102(e) as being anticipated by Bartles US PGPub 2003/0150807 A1 (hereinafter referred to as Bartels).

Regarding claim 12, Bartels discloses a method of improving filtration performance of hollow fiber membranes including steps for backwashing the membrane. Paragraph [0005] of Bartels discloses "immersing the membrane in a liquid suspension and performing filtration of the liquid suspension through a wall of the membrane", while paragraph [0048] describes "applying a gas at a pressure below bubble point to the liquid permeate" within the lumen to backwash the system as claimed.

Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claims 2-11 are rejected under 35 U.S.C. 103(a) as being unpatentable over Selbie US Patent 6,202,475 (hereinafter referred to as Selbie) in view of Bartels.

Regarding **claim 5**, Selbie discloses a method of determining flow rate through a membrane and testing the integrity of the membrane via a pressure decay method. A preferred method of performing the test consists of wetting a membrane, applying a gas to one side of the membrane below bubble point of the pores and measuring the gas flow across the membrane with a pressure decay measurement (column 1 lines 49-61). The method is further described in column 3 lines 8-16 as pressurizing the lumens to a test pressure while keeping the feed-side full ("allowing a gas pressure in the lumen of the membrane to increase to a predetermined level above a pressure on another side of the membrane"), sealing the filtrate side ("isolating the lumen of the membrane"), and monitoring the drop in pressure. Since the pressure decay is related directly to the membrane integrity, it would need to be compared "against a predetermined value" to decide if the membrane integrity is acceptable. Selbie does not disclose specifically a method of backwashing the membrane as claimed.

Bartels discloses a method for improving filtration performance of hollow fiber membranes comprising backwashing procudures. Figure 9 and paragraph [0048] describe a method of backwashing by introducing a gas pressure below the bubble point on the lumen side of the membrane. Since the method of Selbie also mentions applying gas pressure below bubble point to one side of a membrane (in this case the

lumen side), it would have been obvious to one of ordinary skill in the art at the time of invention to use this step in a similar manner as disclosed by Bartels to backwash the system as well while measuring the integrity of the membrane within to keep the membrane free of fouling components, therefore lengthening its lifetime.

Regarding **claim 2**, by combining the teachings of Selbie with those of Bartels, the backwashing and integrity testing would be linked and thus the integrity test could be performed during every backwash if desired.

Regarding **claim 3**, by combining the teachings of Selbie with those of Bartels, the backwashing and integrity testing would be linked and thus the integrity test could be performed after any number of backwashes desired.

Regarding **claim 4**, Selbie discloses a method of calculating the logarithmic reduction values (LRV) for a filtration system. Selbie does not specifically disclose calculating a LRV of 4, however since the LRV corresponds to a value based on the reduction of particles in the fluid, a value of 4 would reduce the concentration of an influent by 99.99%. Therefore, the LRV could be calculated based on the desired maximum allowed concentration of the effluent and could be 3 if a less filtered soulution was acceptable or 5 if a more filtered solution was needed.

Regarding **claim 6**, the backwashing methods disclosed in Bartels are all typically described as taking a minimum of between 1-5 seconds. Since the integrity test method of Selbie is essentially the same as the claimed invention, the addition of time due to backwashing would be within the claimed 30 seconds to one minute.

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Regarding **claim 7**, the backwashing methods disclosed in Bartels are all typically described as taking a minimum of between 1-5 seconds. Since the integrity test method of Selbie is essentially the same as the claimed invention, the addition of time due to backwashing would be within the claimed five to ten seconds.

Regarding **claim 8**, backwashing and integrity testing in a system implies the filter is to be reused, thus the process of filtration would recommence once the backwashing and integrity test is complete. The method of raising a pressure on the exterior of a membrane to pass the liquid suspension through and into the lumen is known in the art and is described in paragraph [0005] of Bartels as well.

Regarding **claim 9**, Selbie discloses a method of determining flow rate through a membrane and testing the integrity of the membrane via a pressure decay method. A preferred method of performing the test consists of wetting a membrane, applying a gas to one side of the membrane below bubble point of the pores and measuring the gas flow across the membrane with a pressure decay measurement (column 1 lines 49-61). The method if further described in column 3 lines 8-16 as pressurizing the lumens to a test pressure while keeping the feed-side full, sealing the filtrate side, and monitoring the drop in pressure (rate of gas pressure decay). Since the pressure decay is related directly to the membrane integrity, it would need to be compared "against a predetermined value" to decide if the membrane integrity is acceptable. Selbie does not disclose specifically a method of backwashing the membrane as claimed.

Bartels discloses a method for improving filtration performance of hollow fiber membranes comprising backwashing procedures. Figure 9 and paragraph [0048] describe a method of backwashing by introducing a gas pressure below the bubble point on the lumen side of the membrane. Since the method of Selbie also mentions applying gas pressure below bubble point to one side of a membrane (in this case the lumen side), it would have been obvious to one of ordinary skill in the art at the time of invention to use this step in a similar manner as disclosed by Bartels to backwash the system as well while measuring the integrity of the membrane within to keep the membrane free of fouling components, therefore lengthening its lifetime.

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Regarding claim 10, the method of Selbie is described in column 3 lines 8-16 as pressurizing the lumens to a test pressure while keeping the feed-side full, thus reading on "allowing a gas pressure in the lumen of the membrane to increase to a predetermined level above a pressure on the external wall" as the external wall would be the outside of the lumen.

Regarding claim 11, the method as disclosed by Selbie in view of Bartels allows for the backwashing to occur as the pressure is introduced into the lumen, thus the increase to the predetermined level as claimed, occurs after the step of backwashing.

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Mark Shabman whose telephone number is (571) 270Application/Control Number: 10/597,903

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3263. The examiner can normally be reached on M-F 7:30am - 5:00pm, EST

(Alternating Fridays Off).

If attempts to reach the examiner by telephone are unsuccessful, the examiner's

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supervisor, Hezron Williams can be reached on (571) 272-2208. The fax phone number

for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the

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